EXTORNEY DOCKET NO.: LOTFI 22-2

SEP 0 2 2000 15

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Ashraf W. Lotfi, et al.

Serial No.:

09/448,856

Filed:

November 23, 1999

Title:

SiC NMOSFET FOR USE AS A POWER SWITCH AND

A METHOD OF MANUFACTURING THE SAME

Group:

2811

Examiner:

Ori Nadav

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313, on (Date)

(Printed or typed samp of person signing the certificate)

(Signature of the person signing the certificate)

Sir:

REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. § 1.111

In response to the Examiner's Action mailed May 30, 2003, please reconsider the aboveidentified application for the following reasons.

IN THE CLAIMS:

Claims 1-43 were previously canceled without prejudice or disclaimer.

44. (Previously Presented)

A semiconductor device, comprising:

a lateral metal-oxide semiconductor field effect transistor (MOSFET), including:

a silicon carbide tub located within a trench formed in a conductive substrate;

PATENT RECON.

PATENT RECON.

10 SEP-4 2013

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